

Docket No.: 060188-0031

lFn
PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of : Customer Number: 53080
Kentaro SHIOMI, et al. : Confirmation Number: 6677
Application No.: 09/779,440 : Group Art Unit: 2132
Filed: February 09, 2001 : Allowed: June 28, 2007
For: LSI DESIGN METHOD AND VERIFICATION METHOD
Examiner: Jung W. Kim

REQUEST FOR ACKNOWLEDGEMENT OF THE CITED ART

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

We are in receipt of the Notice of Allowance dated June 28, 2007.

In reviewing the file, it is noted that we have not received a **complete** acknowledgement of the Information Disclosure Statement and cited art filed December 12, 2006. Specifically, US6,157,947 was not initialed by the Examiner. Enclosed are copies of the Information Disclosure Statement, PTO-1449 and stamped return postcard acknowledgement. Also enclosed is a copy of the partially initialed PTO-1449 form forwarded to Applicant with the Notice of Allowance of June 28, 2007.

Applicant hereby respectfully requests that:

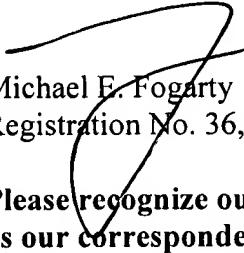
- (1) the completely acknowledged PTO-1449 be furnished to Applicant; and

No.: 09/779,440

(2) the record be clarified to confirm that the cited art has been considered and made of record.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP



Michael E. Fogarty
Registration No. 36,139

Please recognize our Customer No. 53080
as our correspondence address.

600 13th Street, N.W.
Washington, DC 20005-3096
Phone: 202.756.8000 MEF:KH
Facsimile: 202.756.8087
Date: July 20, 2007